



Attorney Docket No.: SAM-0526
Application Serial No.: 10/796,507
Reply to Office Action of: February 16, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Ki Hwan Park, *et al* Examiner: El Arini, Zeinab
Serial No.: 10/796,507 Group Art Unit: 1746
Filing Date: March 9, 2004
Title: METHOD OF RINSING AND DRYING SEMICONDUCTOR
SUBSTRATES (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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Date

Christina Harris

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

The following is in response to the Office Action dated February 16, 2006, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.